


<b>Search Notes</b> 	<b>Application/Control No.</b>		<b>Applicant(s)/Patent under Reexamination</b>	
	10/604,641		PONZIO, MASSIMO	
	<b>Examiner</b>		<b>Art Unit</b>	
	José V. Chen		3637	

SEARCHED			
Class	Subclass	Date	Examiner
100	55.1	3/22/06	JV
	55.3		
	57.11		
198	803.11		
	803.01		
269	56		
	55		
	29.2		
<del>JR PACE 10/17/06 JV</del>			
<del>JP PACE 4/16/07 JV</del>			
<del>JP PACE 11/04/07 JV</del>			

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Pa & Soc Sources Pa Soc Br	3/22/06	JV
<del>JP PACE</del>	<del>10/17/06</del>	<del>JV</del>
<del>JP PACE</del>	<del>4/16/07</del>	<del>JV</del>
<del>JP PACE</del>	<del>11/04/07</del>	<del>JV</del>